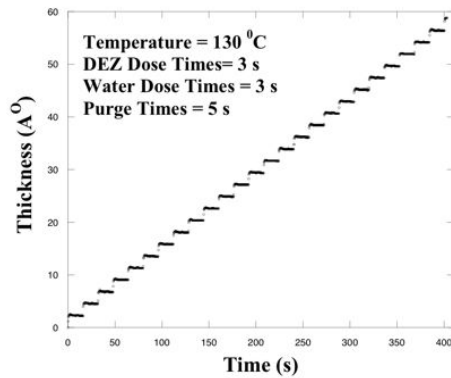
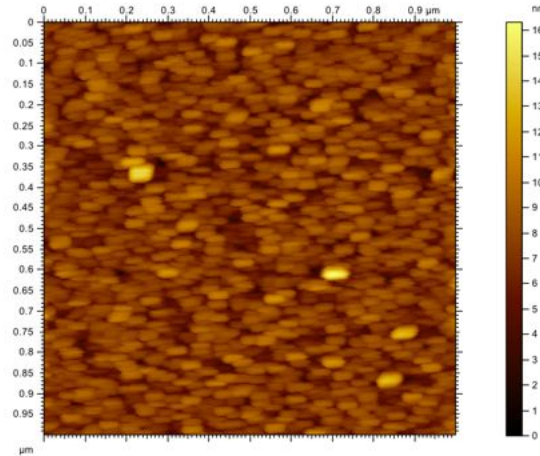


Atomic-layer deposition of ZnO films.

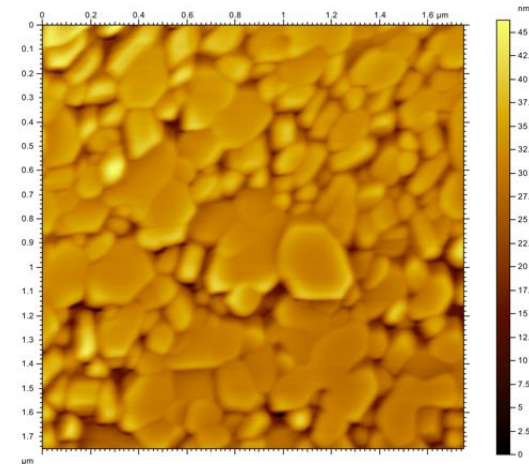
- Atomic-layer deposition provides exceedingly fine control over the growth of oxide and other films.



Step-like growth:
Each step corresponds
to a single atomic layer



Resultant
conformal
growth of ZnO
platelets.



Upon annealing,
these coalesce
into a
continuous film.